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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	10/577,274
		Filing Date	April 26, 2006
		First Named Inventor	DELATRE, Cyril
		Art Unit	TBA
		Examiner Name	TBA
Sheet	1	of	2
		Attorney Docket Number	10404.041

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/BF/	AA	6,040,193	03/21/2000	WINKLER, ET AL.	
	AB	2004/0219547	11/04/2004	FREY, ET AL.	
	AC	2004/0039116	02/26/2004	VINET, ET AL.	
	AD	5,489,653	02/06/1996	CHARLES, ET AL.	
	AE	6,210,894	04/03/2001	BRENNAN	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	* ⁶
/BF/	BA	WO 02-16023	02/28/2002	PROTOGENE LABORATORIES, INC.		
	BB	WO 99/03684	01/28/1999	CAMBRIDGE SENSORS LIMITED		
	BC	WO 00/36145	06/22/2000	COMMISSARIAT A L'ENERGIE ATOMIQUE		
	BD	WO 02/090573	11/14/2002	INFINEON TECHNOLOGIES AG.		
	BE	WO 03/059518	07/24/2003	UNIVERSITY COLLEGE CORK-NATIONAL UNIVERSITY OF IRELAND CORK		
	BF	WO 02/41992	05/30/2002	SIEMENS AKTIENGESellschaft		
	BG	WO 03/041863	05/22/2003	TECHNISCHE UNIVERSITEIT DELFT		
	BE	FR 2 818 662	06/28/2002	COMMISSARIAT A L'ENERGIE ATOMIQUE		
	BF	EP 0 561 722	09/22/1993	BIO MERIEUX		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * Applicant's unique citation designation number (optional). * See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. * Enter Office that issued the document, by the two-letter code (WIPO Standard ST 3). * For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. * Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. * Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			* ²
/BF/	CA	Azek, et al. "Hybridization Assay at a Disposable Electrochemical Biosensor for the Attomole Detection of Amplified Human Cytomegalovirus DNA; Analytical Biochemistry 284, pp.107-113 (2000)			
/BF/	CB	Bratten, et al. "Micromachining Sensors for Electrochemical Measurement in Subnanoliter Volumes" Analytical Chemistry, 1997 Vol. 69, No. 2, pp. 253-258 January 15, 1997			

Examiner Signature	/Betty Forman/	Date Considered	07/29/2009
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PTO/SB/08a/b (05-03)

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/BF/	CC	Jansen, et al. " The Black Silicon Method: A Universal Method for Determining the Parameter Setting of a Flourine-Based Reactive Ion Etcher in Deep Silicon Trench Etching with Profile Control" J. Micromech. Microeng. 5 pp. 115-120 (1995)	
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